

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Yuh-Fong Hwang

Confirmation No. 3979

Serial No.: 10/792,246

Group Art Unit: 2125

Filed: March 3, 2004

Examiner: Cabrera, Zoila

For: METHOD AND SYSTEM FOR
MASK FABRICATIONO PROCESS
CONTROL

TKHR Ref. 252011-1950
Top-Team Ref. 0503-A30088US

AMENDMENT AND RESPONSE TO RESTRICTION REQUIREMENT

Mail Stop: Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

The outstanding Office Action with a restriction requirement mailed September 6, 2006 has been carefully considered. In response thereto, Applicant submits the following amendments and election.